PICA Power Piezo Actuator

Preloaded Piezo Actuators (HVPZT) with Sensor Option

Fields of application

- Active vibration absorber
- Adaptive mechanics
- Precision mechanics / micromechanics
- Optics
- Measuring technology / interferometry
- Adaptive systems technology
- Switching
- Laser tuning
- Force generation / materials testing
- Nanotechnology

PICA Power piezo actuators for high loads
PICA Power high-load stack actuators are reliable and offer long travel ranges with large loads. The actuators are suitable for demanding loads with high temperatures.

Suitable for sophisticated vacuum applications
Piezo actuators do not require lubrication and do not cause abrasion. Versions are available for vacuum to $10^{-9}$ hPa and for particularly high or low operating temperatures.

P-216

- Travel range to 180 µm
- Push force capacity to 4500 N
- Pull force capacity to 500 N
- Sub-ms response time
- Subnanometer resolution
- Optional: Suitable for vacuum, high temperature
## Specifications

<table>
<thead>
<tr>
<th></th>
<th>P-216.1S</th>
<th>P-216.2S</th>
<th>P-216.4S</th>
<th>P-216.8S</th>
<th>P-216.9S</th>
<th>Unit</th>
<th>Tolerance</th>
</tr>
</thead>
<tbody>
<tr>
<td><strong>Operating voltage range</strong></td>
<td>0 to 1000</td>
<td>0 to 1000</td>
<td>0 to 1000</td>
<td>0 to 1000</td>
<td>0 to 1000</td>
<td>V</td>
<td></td>
</tr>
<tr>
<td><strong>Motion and positioning</strong></td>
<td></td>
<td></td>
<td></td>
<td></td>
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<td></td>
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<tr>
<td>Travel range, closed loop</td>
<td>15</td>
<td>30</td>
<td>60</td>
<td>120</td>
<td>180</td>
<td>µm</td>
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<tr>
<td>Resolution, closed loop</td>
<td>0.3</td>
<td>0.6</td>
<td>1.2</td>
<td>2.4</td>
<td>3.6</td>
<td>nm</td>
<td>typ.</td>
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<tr>
<td>Resolution, open loop</td>
<td>0.15</td>
<td>0.3</td>
<td>0.6</td>
<td>1.2</td>
<td>1.8</td>
<td>nm</td>
<td>typ.</td>
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<tr>
<td>Linearity error</td>
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<td>0.2</td>
<td>0.2</td>
<td>0.2</td>
<td>0.2</td>
<td>%</td>
<td>typ.</td>
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<tr>
<td><strong>Mechanical properties</strong></td>
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<td></td>
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<td></td>
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<tr>
<td>Static large-signal stiffness in motion direction*</td>
<td>210</td>
<td>140</td>
<td>80</td>
<td>50</td>
<td>32</td>
<td>N/µm</td>
<td>±20 %</td>
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<tr>
<td>Resonant frequency, no load</td>
<td>17</td>
<td>12</td>
<td>7</td>
<td>4.5</td>
<td>3</td>
<td>kHz</td>
<td>±20 %</td>
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<tr>
<td>Push/pull force capacity in motion direction</td>
<td>4500 / 500</td>
<td>4500 / 500</td>
<td>4500 / 500</td>
<td>4500 / 500</td>
<td>4500 / 500</td>
<td>N</td>
<td>max.</td>
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<tr>
<td>Shear load</td>
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<td>36</td>
<td>23</td>
<td>23</td>
<td>23</td>
<td>N</td>
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<td>1</td>
<td>1</td>
<td>1</td>
<td>1</td>
<td>Nm</td>
<td>max.</td>
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<td>Piezo ceramic</td>
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<tr>
<td>Electrical capacitance</td>
<td>130</td>
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<td>500</td>
<td>1000</td>
<td>1500</td>
<td>nF</td>
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<td><strong>Miscellaneous</strong></td>
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<tr>
<td>Operating temperature range</td>
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<td>-40 to 80</td>
<td>-40 to 80</td>
<td>-40 to 80</td>
<td>-40 to 80</td>
<td>°C</td>
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<tr>
<td>Mass</td>
<td>170</td>
<td>200</td>
<td>250</td>
<td>370</td>
<td>480</td>
<td>g</td>
<td>±5 %</td>
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</table>

* Dynamic small-signal stiffness is approx. 50 % higher.

The resolution of the system is only limited by the noise of the amplifier and measuring technology because PI piezo actuators are free of friction.

The operating voltage should not exceed 750 V in continuous operation.

Versions without sensor are available under the P-216.x0 and P-216.x0V order numbers.

Vacuum versions are available under the P-216.xxV order numbers.

Specifications for vacuum versions can differ.

All specifications based on room temperature (22 °C ±3 °C).
Drawings / Images

<table>
<thead>
<tr>
<th></th>
<th>L</th>
<th>A</th>
<th>B</th>
<th>C</th>
<th>D</th>
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<td>P-216.1x</td>
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<td>6</td>
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</tbody>
</table>

P-216, dimensions in mm
Ordering Information

Actuators without sensor

P-216.10
Preloaded piezo actuator, 15 µm, 1000 V, 4500 N

P-216.20
Preloaded piezo actuator, 30 µm, 1000 V, 4500 N

P-216.40
Preloaded piezo actuator, 60 µm, 1000 V, 4500 N

P-216.80
Preloaded piezo actuator, 120 µm, 1000 V, 4500 N

P-216.90
Preloaded piezo actuator, 180 µm, 1000 V, 4500 N

Actuators without sensor, vacuum compatible

P-216.10V
Preloaded piezo actuator, 15 µm, 1000 V, 4500 N, high temperature / vacuum

P-216.20V
Preloaded piezo actuator, 30 µm, 1000 V, 4500 N, high temperature / vacuum

P-216.40V
Preloaded piezo actuator, 60 µm, 1000 V, 4500 N, high temperature / vacuum

P-216.80V
Preloaded piezo actuator, 120 µm, 1000 V, 4500 N, high temperature / vacuum

P-216.90V
Preloaded piezo actuator, 180 µm, 1000 V, 4500 N, high temperature / vacuum

Actuators with sensor

P-216.1S
Preloaded piezo actuator, 15 µm, 1000 V, 4500 N, SGS

P-216.2S
Preloaded piezo actuator, 30 µm, 1000 V, 4500 N, SGS

P-216.4S
Preloaded piezo actuator, 60 µm, 1000 V, 4500 N, SGS

P-216.8S
Preloaded piezo actuator, 120 µm, 1000 V, 4500 N, SGS

P-216.9S
Preloaded piezo actuator, 180 µm, 1000 V, 4500 N, SGS
Actuators with sensor, vacuum compatible

P-216.1SV
Preloaded piezo actuator, 15 µm, 1000 V, 4500 N, SGS, high temperature / vacuum

P-216.2SV
Preloaded piezo actuator, 30 µm, 1000 V, 4500 N, SGS, high temperature / vacuum

P-216.4SV
Preloaded piezo actuator, 60 µm, 1000 V, 4500 N, SGS, high temperature / vacuum

P-216.8SV
Preloaded piezo actuator, 120 µm, 1000 V, 4500 N, SGS, high temperature / vacuum

P-216.9SV
Preloaded piezo actuator, 180 µm, 1000 V, 4500 N, SGS, high temperature / vacuum